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APPLICATION NO	D. F	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/615,042		07/08/2003	Valeriy Sukharev	03-0509	3892
24319	7590	06/17/2004		EXAMINER	
		DRATION	FENTY, JESSE A		
1621 BARBER LANE MS: D-106 LEGAL				ART UNIT	PAPER NUMBER
MILPITA	MILPITAS, CA 95035			2815	
		•		DATE MAILED: 06/17/200	4

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
	10/615,042	SUKHAREV ET AL.					
Office Action Summary	Examiner	Art Unit					
	Jesse A. Fenty	2815					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REF THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a r - If NO period for reply is specified above, the maximum statutory perion - Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the may earned patent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, however, may a reply be tirely within the statutory minimum of thirty (30) day of will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	mely filed ys will be considered timely. the mailing date of this communication. ED (35 U.S.C. § 133).					
Status							
1)⊠ Responsive to communication(s) filed on 18	May 2004.						
2a)⊠ This action is FINAL . 2b)□ TI	•						
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
4a) Of the above claim(s) is/are withd 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) <u>1-14</u> is/are rejected. 7) ☐ Claim(s) is/are objected to.	Claim(s) 1-14 is/are rejected.						
Application Papers							
9)☐ The specification is objected to by the Examiner.							
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. § 119							
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 							
Attachment(s) 1) Notice of References Cited (PTO-892)	4) ☐ Interview Summar	v (PTO-413)					
2) Notice of Neterlands Cited (1 10-032) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/Paper No(s)/Mail Date	Paper No(s)/Mail [

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

2. Claims 1-3 and 5-11 are rejected under 35 U.S.C. 102(e) as being anticipated by Dubin et al. (US 2004/0000720 A1).

In re claims 1, 3 and 8, Dubin (Figs. 2a – 2c) discloses a device and method of forming an interconnect in a substrate (90) which includes one or more dielectric layers (100) and a copper deposit (195, section [0020]), said method comprising:

Forming a trench (205) in the substrate;

Forming a via in the substrate to the copper deposit;

Depositing (section [0027]) an intermediate liner layer (210) in the trench and via and on the copper deposit;

Depositing (section [0030]) an interconnect layer of aluminum-copper alloy (220, sections [0028 - 0029]) on the intermediate layer in the trench and via;

Depositing¹ copper (230) onto the aluminum-copper alloy interconnect line; and

¹ Dubin discloses depositing the copper layer (230) by electroplating (section [0041]). The reference discloses this to be a deposition method. Also see Graf, R., Modern Dictionary of Electronics, 1997, pp. 333, defining electroplating as a deposition method.

Polishing the copper (section [0051]).

In re claim 2, Dubin discloses the method of claim 1, wherein the step of depositing a layer of aluminum-copper alloy comprises depositing the

In re claim 5, Dubin discloses the method of claim 3, wherein the step of depositing an intermediate liner layer comprises depositing Ta/TaN (section [0025]).

In re claim 6, Dubin (Figs. 2a – 2c) discloses an interconnect in a substrate which includes one or more dielectric layers (200), said interconnect comprising a first copper deposit (195), a second copper deposit (230), and an aluminum-copper alloy interconnect layer (220) disposed between and in (electrical) contact with the first and second copper deposits and between the second copper deposit and at least one of the dielectric layers.

In re claim 7, Dubin discloses the device of claim 6, wherein the aluminum-copper alloy interconnect liner has been deposited using a PVD technique.

In re claim 9, Dubin discloses the device of claim 8, wherein the aluminum-copper alloy interconnect liner has been deposited using a PVD technique.

In re claim 10, Dubin discloses the method of claim 8, wherein the intermediate interconnect liner comprises Ta/TaN.

In re claim 11, Dubin discloses the method of claim 1, further comprising depositing the interconnect layer such that said interconnect liner is in contact with the copper deposit.

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Claim Rejections - 35 USC § 103

1. Claims 4 and 12-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Dubin as applied to claims 1, 3 and 8 above, and further in view of Moslehi (U.S. Patent No. 6,124,198).

3. In re claims 4 and 12-14, Dubin discloses the devices of claims 1, 3 and 8, but does not expressly disclose the aluminum-copper alloy comprising aluminum-0.5% copper alloy. However, such a combination of layers is a standard in the industry (Farrar; column 1, lines 65-67; column 2, lines 20-21) and it would have been obvious for one skilled in the art at the time of the invention to use Al-0.5% Cu alloy to line the trench of Lu for the purpose, for example, of improving the electro migration lifetime of the interconnect scheme (Moslehi; column 1, lines 32-38).

Response to Arguments

4. Applicant's arguments with respect to claims 1-14 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

5. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO

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MONTHS of the mailing date of this final action and the advisory action is not mailed until after

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the end of the THREE-MONTH shortened statutory period, then the shortened statutory period

will expire on the date the advisory action is mailed, and any extension fee pursuant to 37

CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event,

however, will the statutory period for reply expire later than SIX MONTHS from the date of this

final action.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Jesse A. Fenty whose telephone number is 571-272-1729. The

examiner can normally be reached on 5/4-9 1st Fri. Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Tom Thomas can be reached on 571-272-1664. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jesse A. Fenty Examiner

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TOM THOMAS SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800